



**ELECTRONIC COPY**

LG646445220  
Report verification at igi.org



August 5, 2024  
IGI Report Number **LG646445220**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **8.43 X 5.90 X 4.04 MM**  
**GRADING RESULTS**  
Carat Weight **2.08 CARATS**  
Color Grade **D**  
Clarity Grade **VVS 2**

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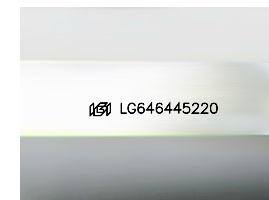
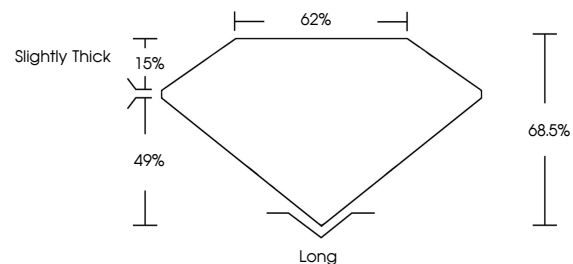
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Color Grade **D**  
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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG646445220**

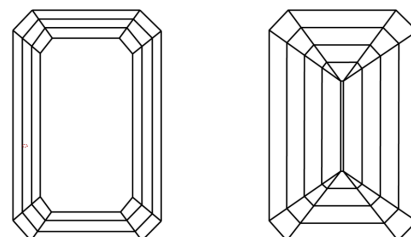
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

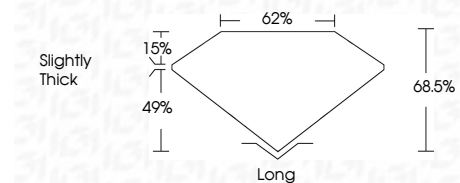
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**EMERALD CUT**  
8.43 X 5.90 X 4.04 MM  
2.08 CARATS  
Color Grade **D**  
Clarity Grade **VVS 2**  
Depth **49%**  
Table **62%**  
Girdle **Slightly Thick**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG646445220**

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